

<b>Notice of References Cited</b>	Application/Control No. 09/821,267	Applicant(s)/Patent Under Reexamination MAEHIRO ET AL.	
	Examiner Chad Zhong	Art Unit 2152	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0193986	12-2002	Schirris, Alphonsus Albertus	704/8
*	B	US-5,813,018	09-1998	Kaji et al.	715/502
*	C	US-6,041,293	03-2000	Shibata et al.	704/4
*	D	US-5,987,402	11-1999	Murata et al.	704/2
*	E	US-5,960,382	09-1999	Steiner, Robert C.	704/2
*	F	US-2003/0063218	04-2003	Kwoh, Daniel S.	348/468
*	G	US-2003/0150300	08-2003	Hu, Bobby	81/63.2
*	H	US-2002/0193986	12-2002	Schirris, Alphonsus Albertus	704/8
*	I	US-2002/0026306	02-2002	Bangalore et al.	704/9
*	J	US-6,609,091	08-2003	Budzinski, Robert L.	704/9
*	K	US-6,321,188	11-2001	Hayashi et al.	704/4
*	L	US-6,658,151	12-2003	Lee et al.	382/229
*	M	US-6,092,036	07-2000	Hamann, Rodney P.	704/8

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.